



03500.011969 REI

PATENT APPLICATION

#18 EK

	IN THE UNITED STATES PA	TENT A	AND TRADEMARK OFFICE	#18EM
				12/3/02
In re Application of:)	Examiner: Luz. L. Alejandro	
NOBUMASA SUZUKI) :	Group Art Unit: 1763	20 / My / 00
Appln. No.: 09/657,971)		
Filed:	September 8, 2000) :	A.	CEIVED
For:	MICROWAVE PLASMA PROCESSING APPARÅTUS)	TC	12002
	AND METHOD THEREFOR)	November 21, 2002	· 100

The Commissioner for Patents **Box AF** Washington, D.C. 20231

SUPPLEMENTAL AMENDMENT AFTER FINAL ACTION **AND** PETITION FOR EXTENSION OF TIME

Sir:

In response to the Final Action dated December 21, 2001, from which a timely Notice of Appeal was filed on June 21, 2002, Applicant petitions to extend the time for taking further action to November 21, 2002.

00000066 09657971 11/27/2002 CV0111 920.00 OP 01 FC:1253

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

November 21, 2002 (Date of Deposit)

Peter Saxon, Reg. No.: (Name of Attorney for Applicant)

November 21, 2002 Date of Signature